NOV 0 9 2004

OKI.557

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Takeshi Morita

Examiner: Unknown

Serial No.: 10/627,734

Attorney Docket No.: OKI.557

Filed: July 28, 2003

Confirm. No.: 3806

For:

METHOD FOR ESTIMATING REMAINING FILM THICKNESS DISTRIBUTION, METHOD FOR DESIGNING PATTERNING MASK USING THE METHOD FOR ESTIMATING REMAINING FILM THICKNESS DISTRUBUTION, AND METHOD

FOR MANUFACTURING SEMICONDUCTOR DEVICES BY USING

PATTERNING MASK DESIGNED BY USING THE METHOD FOR ESTIMATING

REMAINING FILM THICKNESS DISTRIBUTION

## **CLAIM OF PRIORITY**

U.S. Patents and Trademark Office 2011 South Clark Place Crystal Plaza Two, Mail Stop Arlington, VA 22202

Sir:

Date: March 22, 2004

Applicant, in the above-identified application, hereby claims the priority date under the International Convention of the following Japanese application:

Appln. No. 2001-219979

filed July 29, 2002

as acknowledged in the Declaration of the subject application.

A certified copy of said application is being submitted herewith.

Respectfully submitted,

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## 日本国特許庁 JAPAN PATENT OFFICE

別紙添付の審類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed vith this Office.

出願年月日 Date of Application:

2002年 7月29日

出 頤 番 号 Application Number:

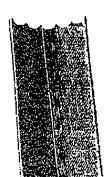
特願2002-219979

[ST. 10/C] :

[JP2002-219979]

M 願 人 pplicant(s):

沖電気工業株式会社



特許庁長官 Commissioner, Japan Patent Office 2003年 8月21日

今井康



ATTY DOCKET#: O

OKI.557

APPLICANT: Takeshi Morita

**DUE DATE:** 

SERIAL NO.: 10/627,734

FILING DATE; July 28, 2003

TITLE: METHOD FOR ESTIMATING REMAINING FILM THICKNESS

DISTRIBUTION, METHOD FOR DESIGNING PATTERNING

MASK...

RECEIPT OF THE FOLLOWING PAPERS IS ACKNOWLEDGED:

Claim of Priority Letter; and Priority Document.

MAR 2 2 2004

**DATE:** March 22, 2004

[Check No.\_\_n/a]